

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**INFORMATION DISCLOSURE STATEMENT**

In re Patent Application of:	)	
	)	Group Art Unit: 2822
Toshiharu Yanagida	)	
	)	Examiner: Not Yet Assigned
Application No. 09/385,959	)	
Filed: August 30, 1999	)	
For: <b>SEMICONDUCTOR APPARATUS AND</b>	)	
<b>PROCESS OF PRODUCTION THEREOF</b>	)	

Commissioner For Patents  
P.O. Box 1450  
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S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-SB08A form, in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent. These references were cited in an Office Action issued on April 30, 2008, in connection with Japanese application no. JP11-234661. Copies of the foreign references and machine translations are attached as is a copy of the Japanese office action.

Respectfully submitted,

/David R. Metzger/ (Reg. No. 32,919)

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